



IFW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ryoji HOSHI et al.

Group Art Unit: 1722

Application No.: 10/525,244

Examiner: G. RAO

Filed: February 22, 2005

Docket No.: 122810

For: SINGLE CRYSTAL, SINGLE CRYSTAL WAFER, EPITAXIAL WAFER, AND  
METHOD OF GROWING SINGLE CRYSTAL

**STATUS INQUIRY LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please telephone our firm's Patent Application Filing Department at 703-836-6400 with the status of the above-identified patent application, including an indication as to when the next communication can be expected.

Respectfully submitted,

  
William P. Berridge  
Registration No. 30,024

David R. Kemeny  
Registration No. 57,241

WPB:DRK/ejw

Date: March 7, 2007

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**